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SERIAL NUMBER 10/795,847	FILING DATE 03/08/2004 RULE	CLASS 438	GROUP ART UNIT 2822	ATTORNEY DOCKET NO. SC13115TP
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APPLICANTS

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** CONTINUING DATA ***** NO

KBD

** FOREIGN APPLICATIONS ***** NO

KBD

IF REQUIRED, FOREIGN FILING LICENSE GRANTED

** 05/25/2004

Foreign Priority claimed 35 USC 119 (a-d) conditions met	<input type="checkbox"/> yes <input checked="" type="checkbox"/> no <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance	STATE OR COUNTRY TX	SHEETS DRAWING 2	TOTAL CLAIMS 21	INDEPENDENT CLAIMS 4
Verified and Acknowledged	Examiner's Signature: <i>[Signature]</i> Initials: KBD				

ADDRESS

23125

FREESCALE SEMICONDUCTOR, INC.

LAW DEPARTMENT

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AUSTIN, TX

78729

TITLE

Method for forming a semiconductor device having metal silicide

FILING FEE RECEIVED	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time)